

**SUPPLEMENTAL APPLICATION DATA SHEET**

**Application Information**

Application Number:: 10/615,127  
Filing Date:: 07/08/03  
Subject Matter:: Utility  
Title:: PROCESS FOR PREPARING A  
STABILIZED IDEAL OXYGEN  
PRECIPITATING SILICON WAFER  
Attorney Docket Number:: MEMC TP-01-2450 (3009)  
Total Drawing Sheets:: 4  
Small Entity?:: No

**Applicant Information**

Applicant Authority Type:: Inventor  
Primary Citizenship Country:: US  
Status:: Full Capacity  
Given Name:: Robert  
Middle Initial:: J.  
Family Name:: Falster  
City of Residence:: London  
State or Province of Residence:: England  
Country of Residence:: United Kingdom  
Street of Mailing Address:: 22 Compton Terrace  
City of Mailing Address:: London  
State or Province of Mailing  
Address:: England  
Postal Code of Mailing Address:: N1 2UN

Applicant Authority Type:: Inventor  
Primary Citizenship Country:: Russia  
Status:: Full Capacity  
Given Name:: Vladimir

Middle Initial:: V.  
Family Name:: Voronkov  
City of Residence:: Merano  
State or Province of Residence:: Bolzano  
Country of Residence:: Italy  
Street of Mailing Address:: Via Nazionale, 59  
City of Mailing Address:: Merano  
State or Province of Mailing  
Address:: Bolzano  
Postal Code of Mailing Address:: 39012

**Correspondence Information**

Correspondence Customer Number:: 000321

**Representative Information**

Representative Customer Number:: 000321

**Assignee Information**

Assignee Name:: MEMC Electronic Materials, Inc.